



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Zahorik et al.

Serial No.: 10/647,634

Filed: August 25, 2003

For: METHODS FOR SELECTIVE
REMOVAL OF MATERIAL FROM
WAFER ALIGNMENT MARKS

Confirmation No.: 3991

Examiner: L. Vinh

Group Art Unit: 1765

Attorney Docket No.: 2269-3131.6US
(96-1119.06/US)

OK for enter
11/8/06

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 28, 2006
Date



Leta M. Howard
Name (Type/Print)

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed June 29, 2006, the three-month shortened statutory period for response to which expires on September 29, 2006. This response is submitted on or before two months from the mailing date of the Final Office Action.

Listing of the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.